

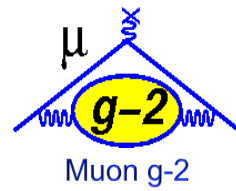
# Gain Studies

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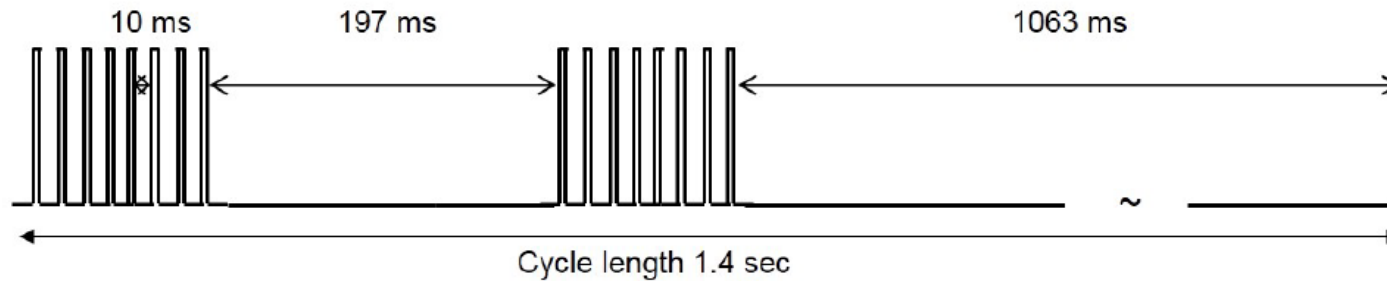
- Recalling the calibration procedure
- Semi-analytical approach of gain fluctuation
- Results on the simulation of Gain Fluctuations using Bias Voltage sagging (Aaron model)
- Effects of Laser pulses
- Conclusion

# Reminder on Calibration procedure



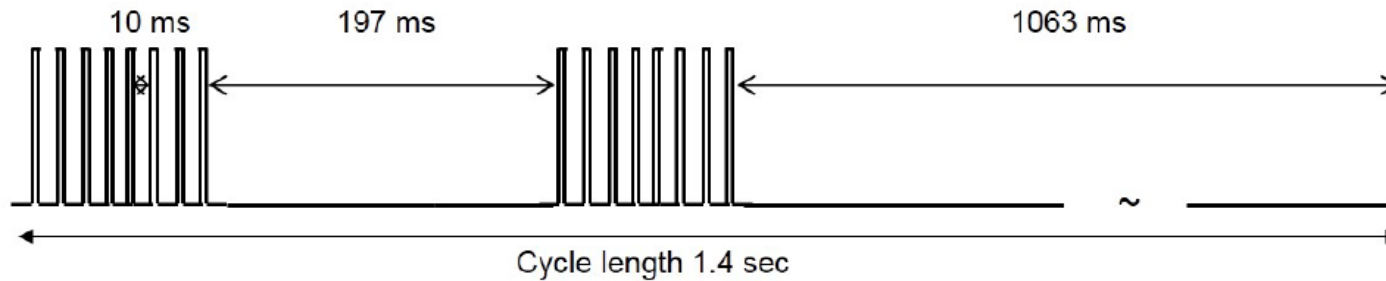
- **Goal** of the Calibration laser system:
  - Monitor the short-term Gain (i.e. within 700  $\mu$ s fill)
  - Fluctuations at sub per mill level (0.04% statistical+0.01% systematics)
- **Basics:**
  1. In-Fill calibration for short term effects on  $G(t)$
  2. Out-of-fill calibration for stability checks
  3. The short term fluctuations will be mostly driven by the Bias Voltage (BV) sagging

# In-fill Calibration: pulsing laser at $\sim 10$ kHz with $\mu$ beam



- Short term gain fluctuations – we pulse the laser along with  $\mu$  beam. A recap of the procedure presented several times in the past:
  - In case of 12.5 kHz laser (80  $\mu$ s) we get  $\sim 8$  points in a fill (700  $\mu$ s)
  - After each subsequent fill, move offset by 5  $\mu$ s  $\Rightarrow$  16 fills for a calibration cycle/event = one beam cycle i.e. 1.4 s.
  - Accuracy for the 140 points separated by 5  $\mu$ s (time bin) – our goal with 2000 cycles / points. This defines a **calibration run** ( $\sim 1-2$  h).

# In-fill Calibration: pulsing laser at $\sim 10$ kHz with $\mu$ beam



- Pulsing the laser for a dedicated time in the day (like 2 hours in the morning) **assumes** that the laser calibration runs represent the gain fluctuations of the entire day.
- A different approach (under study) could be to pulse the laser 1 fill out of XX(10-20) continuously during the day. The calibration runs in this case will be distributed over the whole day and will be a more realistic representative of the muon beam conditions (Intensity, etc...) for the entire day.
- It is important that the laser shouldn't introduce a bias in the gain.

The gain function in a fill is:

$$G(t) = 1 - \alpha E \sum_{i=1}^{n_0} \sum_{k=1}^p f_k \theta(t - t_i) e^{-(t-t_i)/\tau_k}$$

where,

- $n_0$  pulses in a fill. Times  $t_i$  corresponds to the  $i^{\text{th}}$  pulse,  $\alpha E$  = gain drop
- Recovery times are sum of exponentials over  $k$  ( $k > 1$  includes very small lifetimes too).

- $f_k$ ,  $\tau_k$  fraction and recovery time of exponential at  $k$  ( $\sum f_k = 1$ )

Average gain by averaging over all  $t_i$  and energy.

All time averages are the same so:

$$\langle G(t) \rangle = 1 - n_0 \alpha \sum_{k=1}^p f_k \int_0^\infty de \int_0^t ew(e, t') e^{-(t-t')/\tau_k} dt'$$

The two integrals are decoupled

Let:  $\tilde{x} = \int_0^\infty e \epsilon(e) x(e) de$

$$S_{N_k}(t) = \int_0^t e^{-(t-t')/\tau_k} e^{-t'/\tau_\mu} dt'$$

$$S_{a_k}(t) = \int_0^t e^{-(t-t')/\tau_k} e^{-t'/\tau_\mu} \cos \omega t' dt'$$

$$S_{b_k}(t) = \int_0^t e^{-(t-t')/\tau_k} e^{-t'/\tau_\mu} \sin \omega t' dt'$$

Where all time integrals are solved analytically. Here a and b are derived from the decoupled wiggler plot definition

$$\frac{\partial^2 P}{\partial e \partial t} = e^{-\frac{t}{\tau}} (N + a \cos \omega t + b \sin \omega t)$$

# Average Gain Function

Finally:

$$\langle G(t) \rangle = 1 - n_0 \alpha \sum_{k=1}^p f_k (\tilde{N} S_{N_k}(t) + \tilde{a} S_{a_k}(t) + \tilde{b} S_{b_k}(t))$$

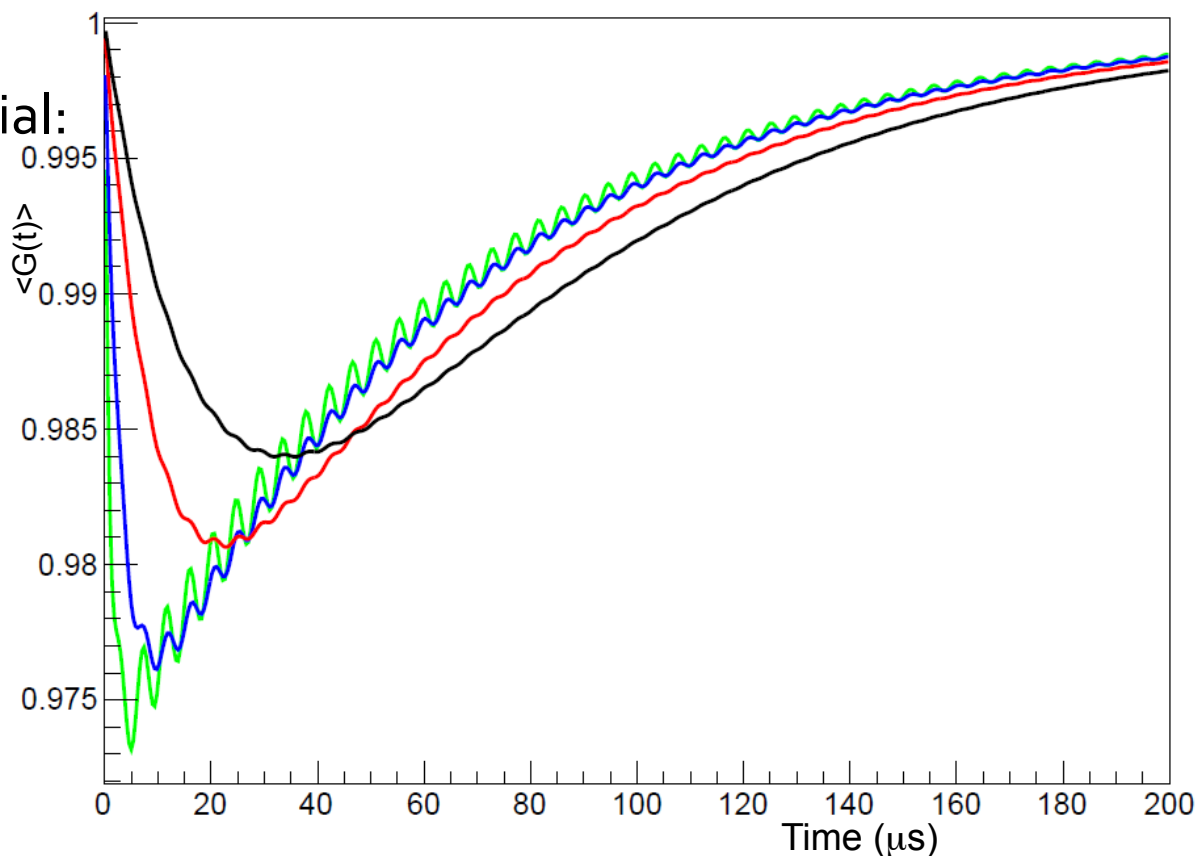
Examples with 1 exponential:

**1  $\mu\text{sec}$**

**3  $\mu\text{sec}$**

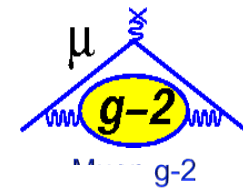
**10  $\mu\text{sec}$**

**20  $\mu\text{sec}$**

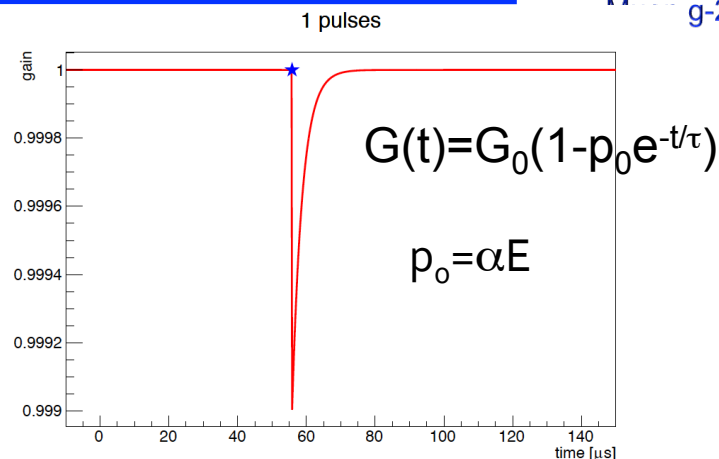




# BV Sagging effect

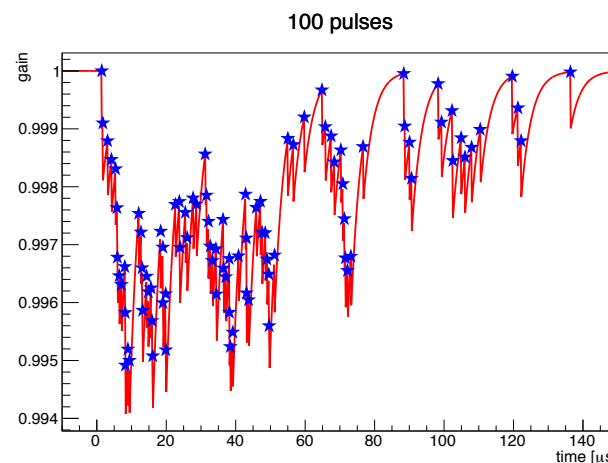


- The BV sagging effect is the convolution of single energy drop with the time distribution of the positrons
- It depends on the rate and intensity of the pulses (positron/laser)



$p_0$  is gain drop, depends on the  $e^-$  energy

- Pulsing at too high frequency affects the BV and changes the gain for the following recovering time ( $\sim 20$ - $60 \mu s$ )
- A safer margin of  $100 \mu s$  between pulses ( $10$  kHz) would allow to neglect the effect due to the previous pulse



Simulation uses a simple exponential decay for  $e^+$  (or laser pulse)

The cumulative gain (for  $n_0$  pulses) can be written as

$$\frac{G(t)}{G_0} = 1 - p_0 n_0 \frac{\tau_r}{\tau_\mu - \tau_r} \left( e^{-t/\tau_\mu} - e^{-t/\tau_r} \right)$$

$p_0 = 6.4 \times 10^{-4}$  for 1500 PE per pulse for  $n_0 = 100$  and  $t_m \sim 32 \mu\text{s}$  taken from JINST paper.

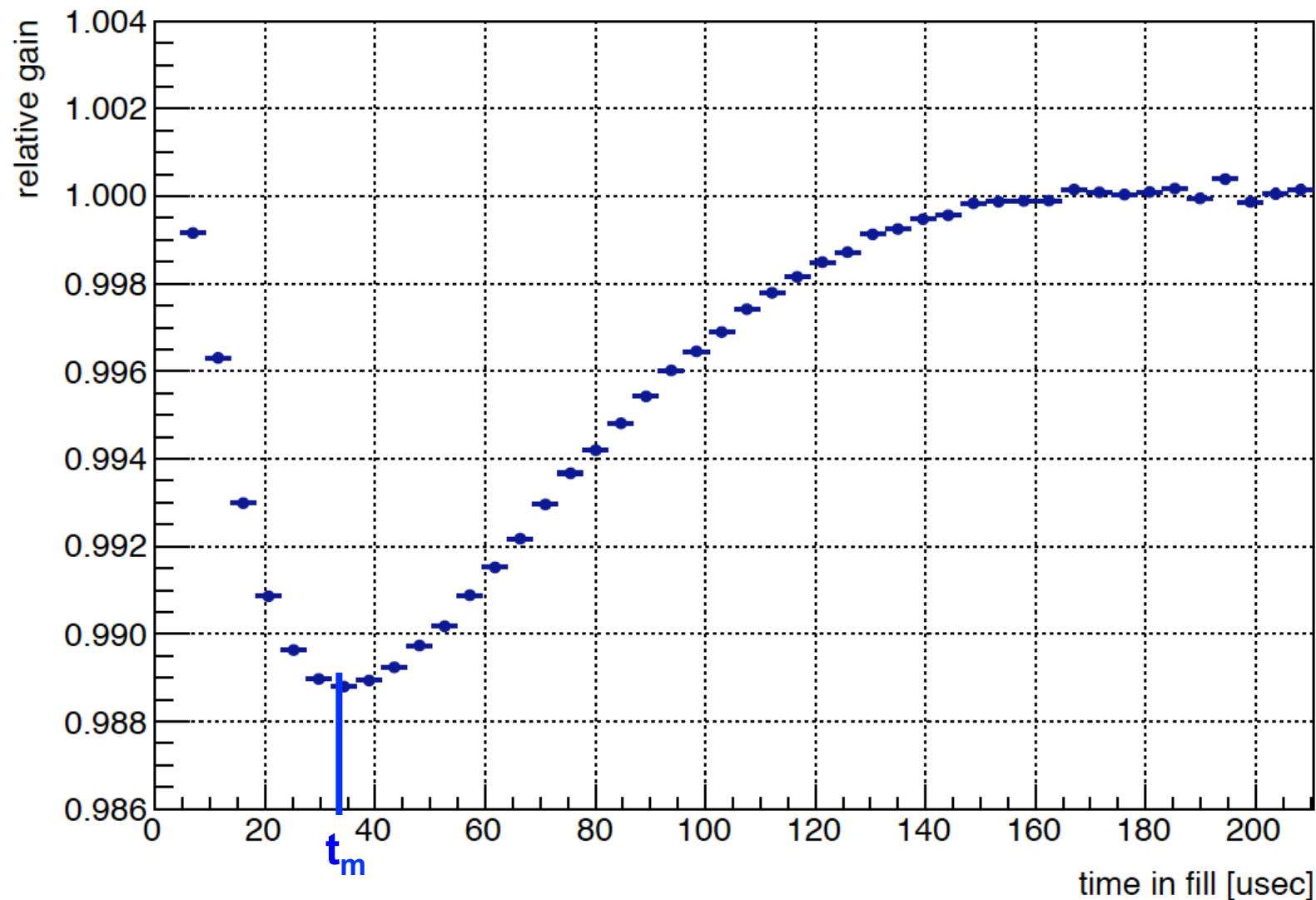
At the minimum

$$t_m = \frac{\tau_\mu \tau_r}{\tau_\mu - \tau_r} \ln \frac{\tau_\mu}{\tau_r}$$

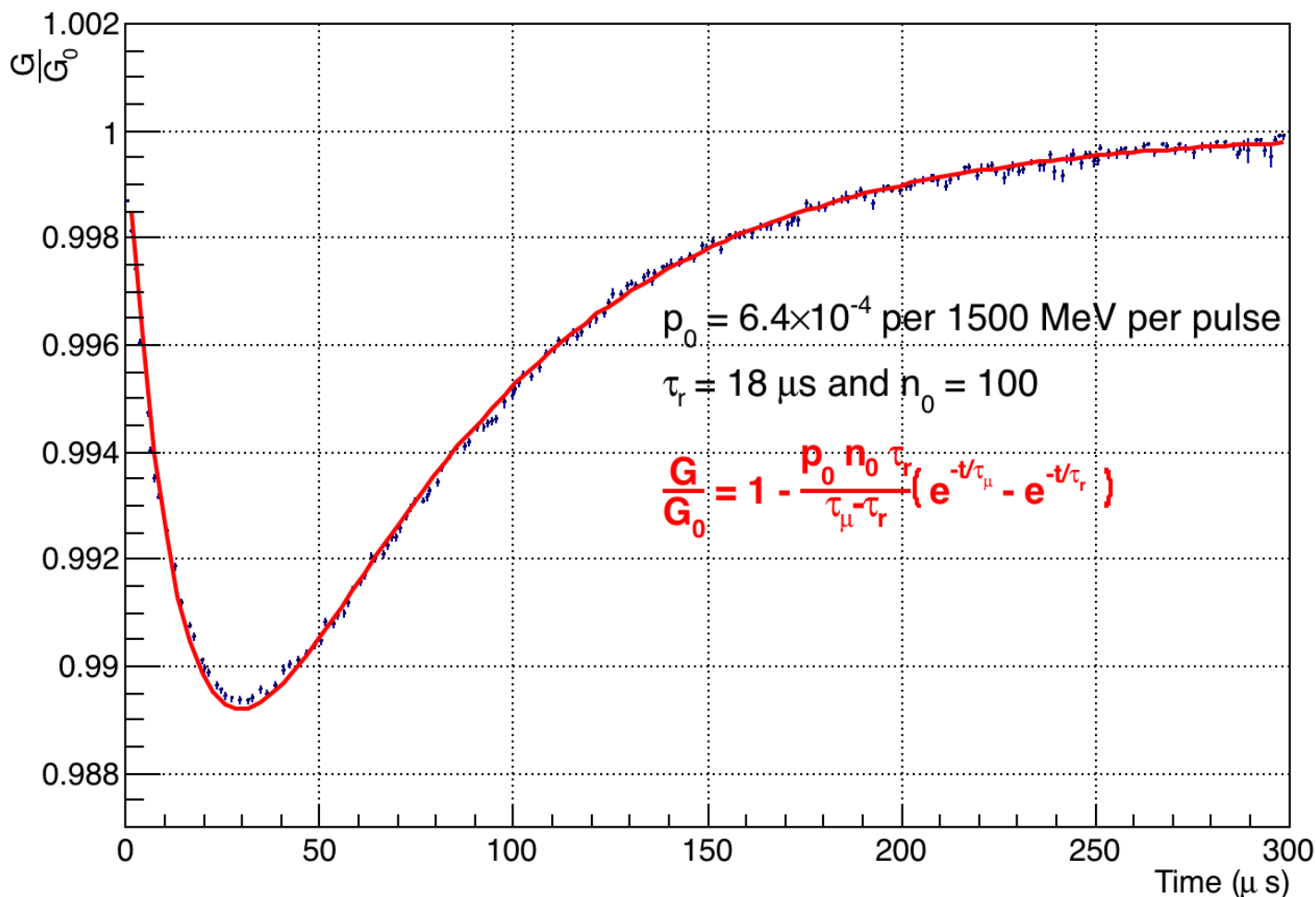
Plugging in the above equation  $t_m \sim 32 \mu\text{s}$  gives  $\tau_r = 18 \mu\text{s}$ . Used a constant  $\alpha = 4.2 \times 10^{-5}$  for 100 MeV pulses which replaces  $p_0$  with  $\alpha E$ . Also  $p_0$  depends on the bias voltage  $p_0 = dG/CdV$

**NOTE:** I have not used oscillatory effects of  $\omega_a$

# JINST SiPM Function for 1500 PE



# Simulated SiPM Function for 1500 PE

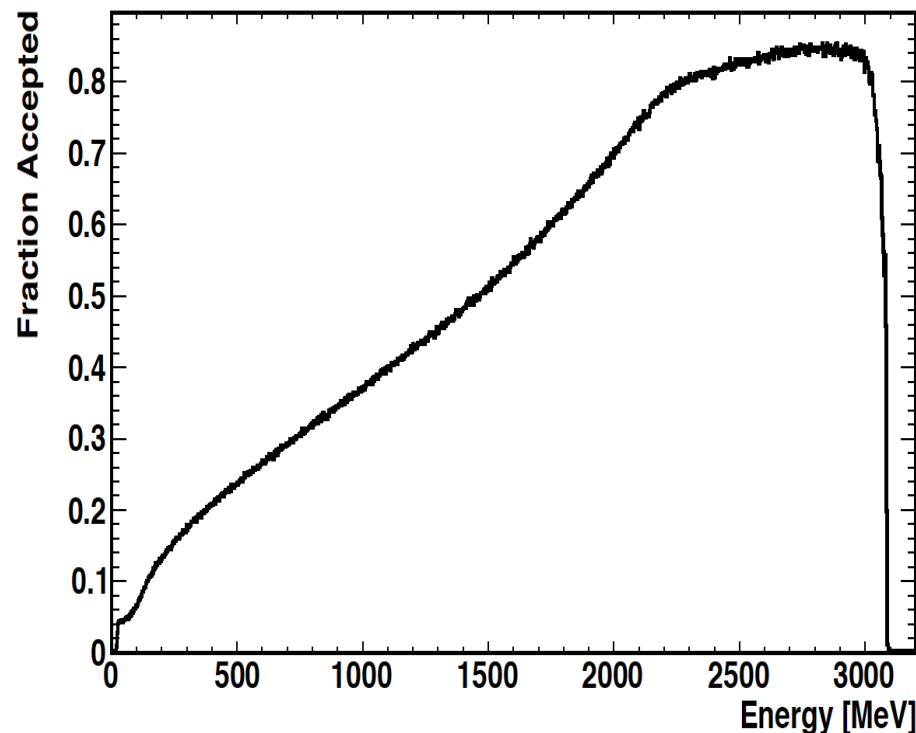
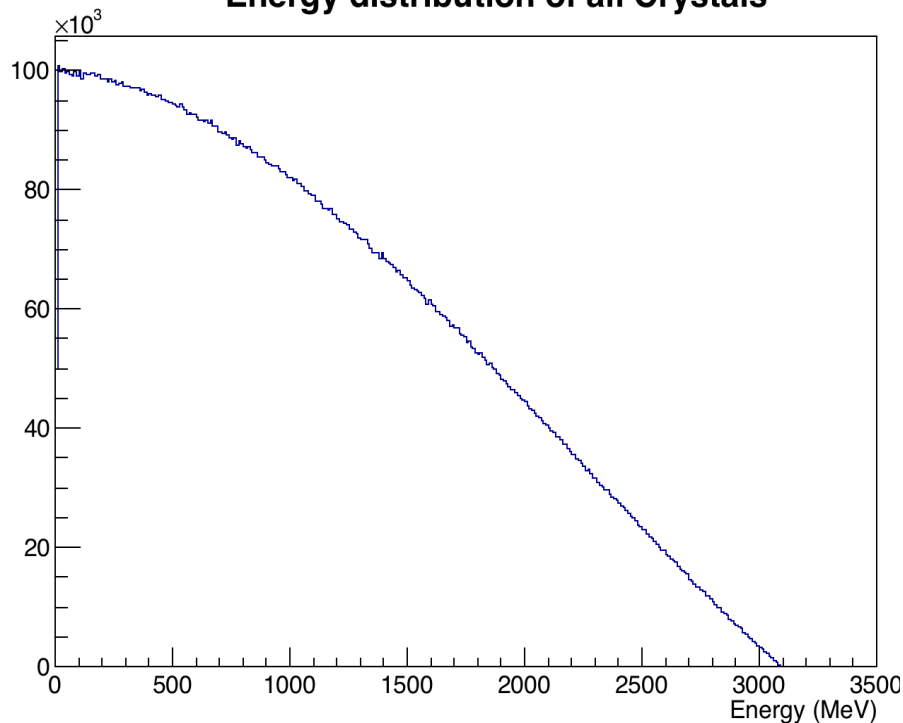


Simulation done with 100 muons and constant energy drop for 1500 PE

# Energy Distribution

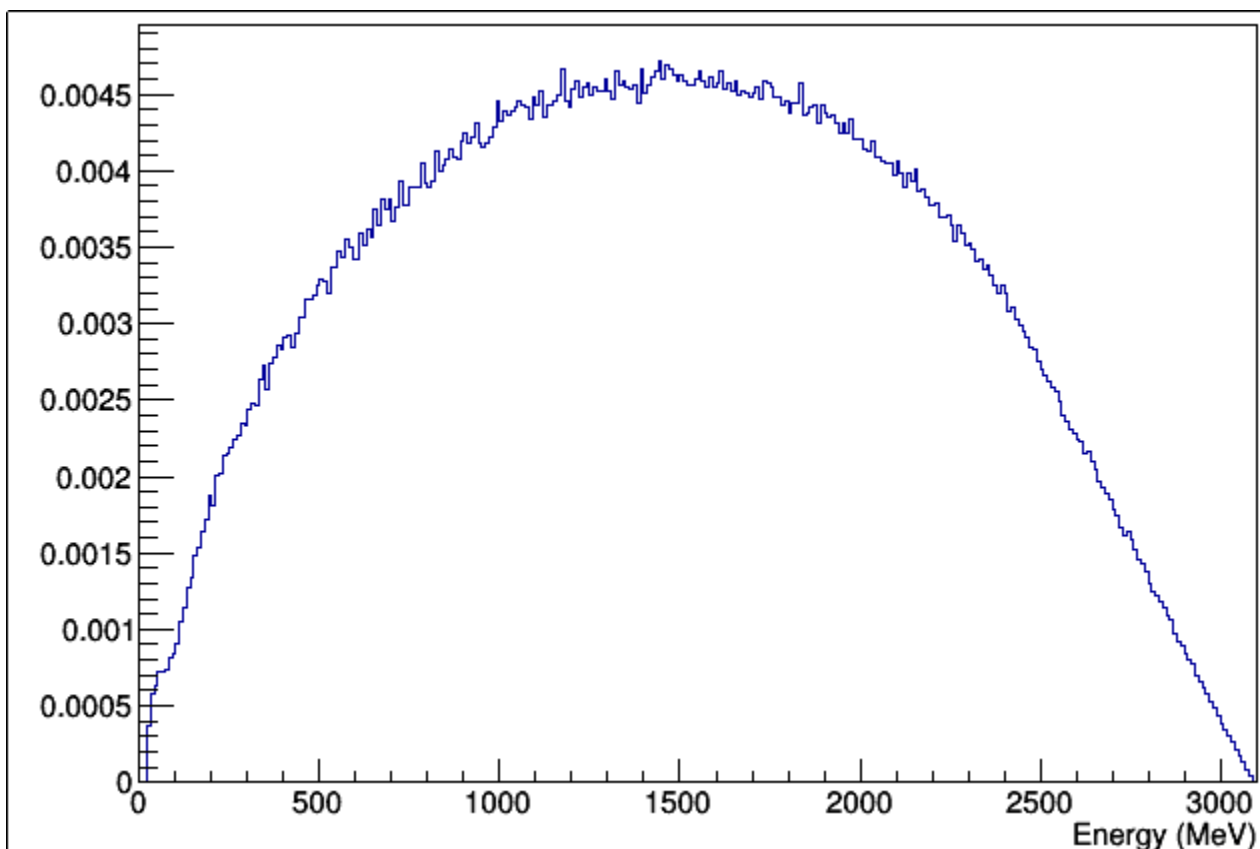
The functional form of the SiPM perturbation in gain depends on the energy of the positrons and the energy of the Laser also changes the bias. Assume 100 positrons hit a crystal with energy given by the plot (total energy distribution of positrons hitting all crystals - left) and the detector acceptance is shown on the right.

Energy distribution of all Crystals



# Energy Probability Distribution

The final probability distribution of energy (applying detector acceptance) used for our 2000 cycles and all fills for all muons used is shown below.

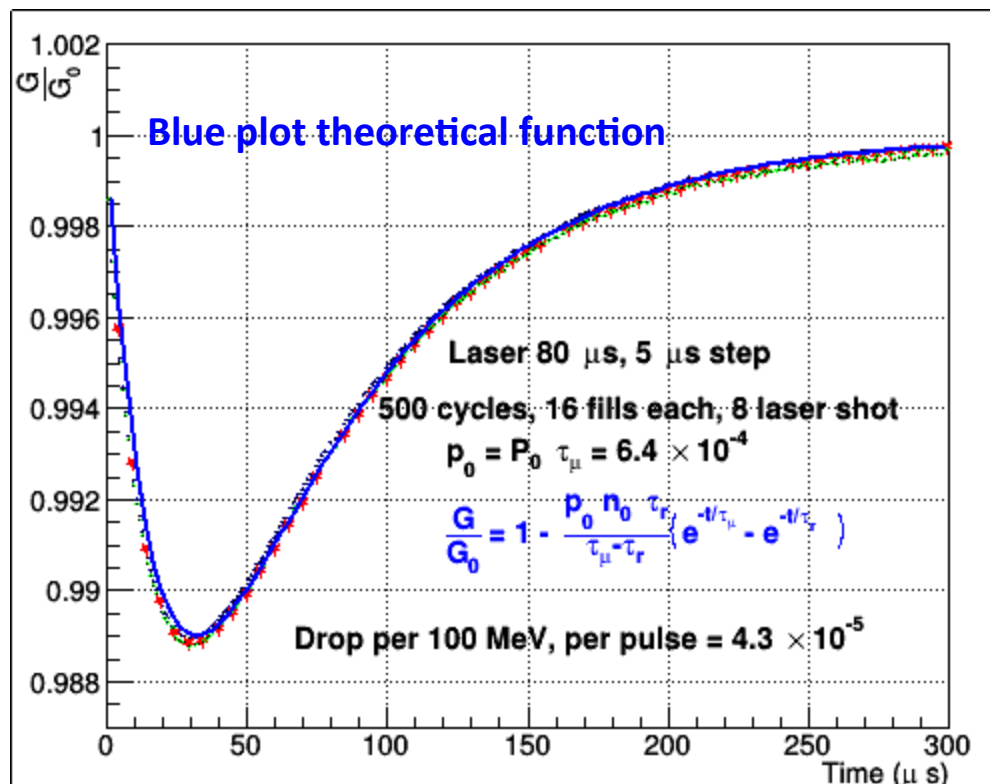


Unless mentioned in these studies we have 100 pulses (positron pulses) in a fill. I reran the simulation with 200 cycles as the energy distribution takes long. I studied the following cases:

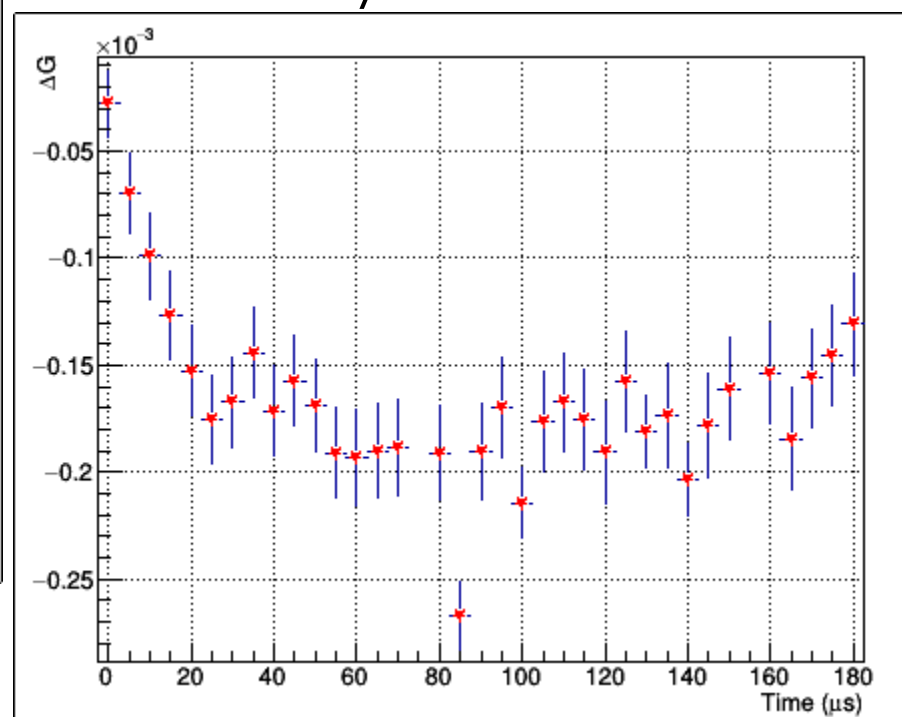
- Muons + laser rate corresponding to 80  $\mu\text{s}$  interval, 5  $\mu\text{s}$  step, 8 laser pulses/fill
- Muons + laser rate corresponding to 160  $\mu\text{s}$  interval, 5  $\mu\text{s}$  step, 4 laser pulses/fill
- Muons + laser rate corresponding to 320  $\mu\text{s}$  interval, 5  $\mu\text{s}$  step, 2 laser pulses/fill
- Muons + laser rate corresponding to 640  $\mu\text{s}$  interval, 5  $\mu\text{s}$  step, 1 laser pulse/fill

The laser shots at 2 GeV ( $p_0 = 8.5 \times 10^{-4}$  )

# Laser Shots with 80 $\mu\text{s}$ rate



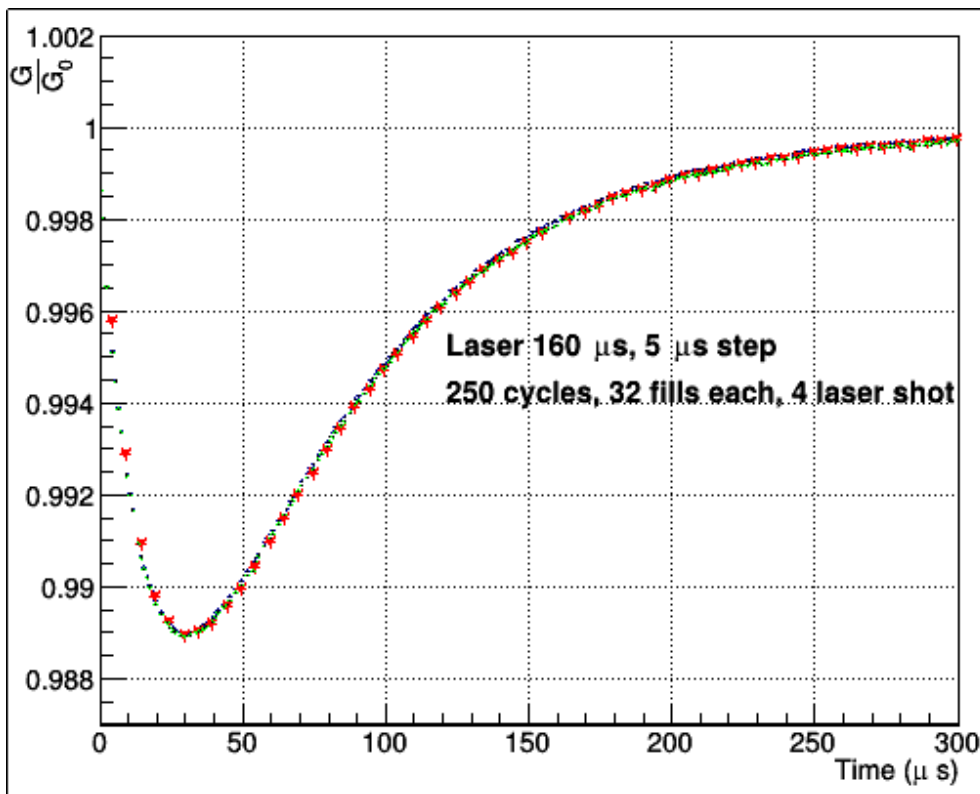
## Difference of Laser and Muons Only



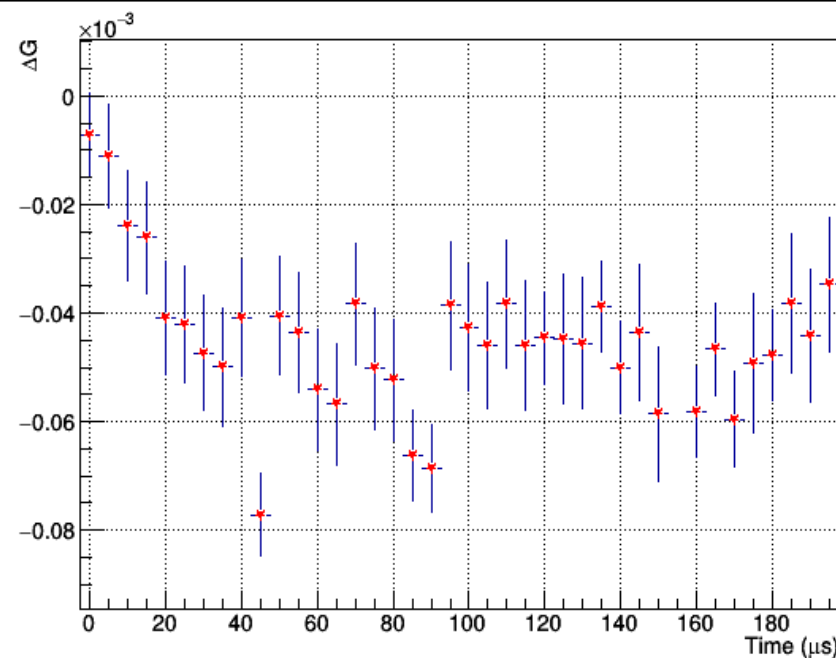
The laser shots at 2 GeV contribute to a larger drop in gain. This explains the negative values.



# Laser Shots with 160 $\mu\text{s}$ rate

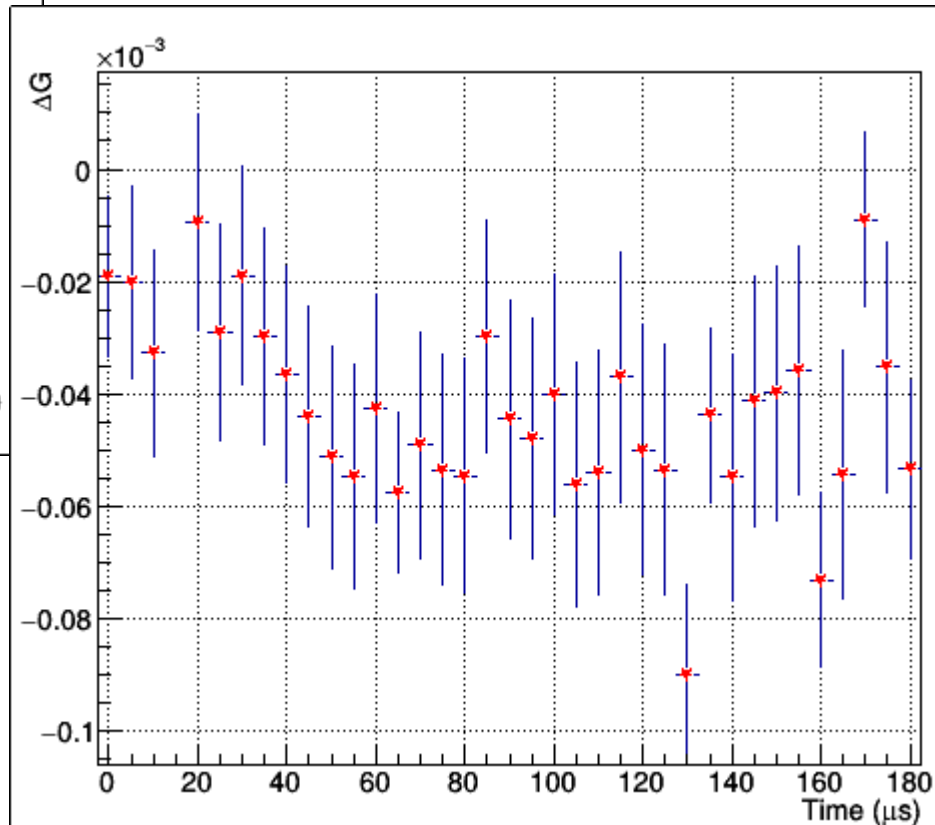
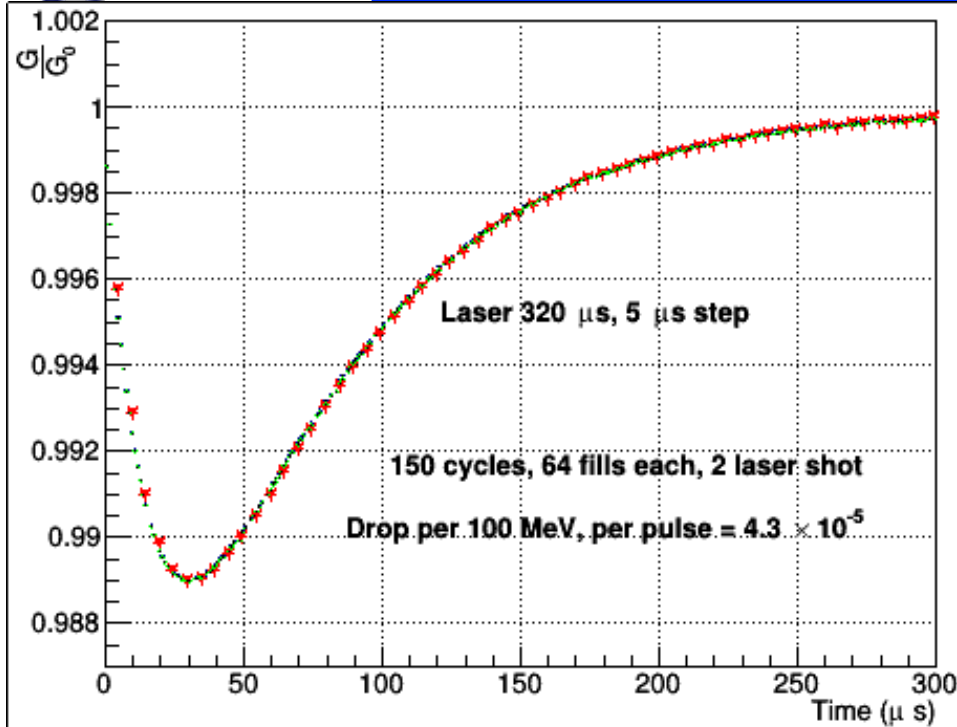


Difference of Laser and  
Muons Only

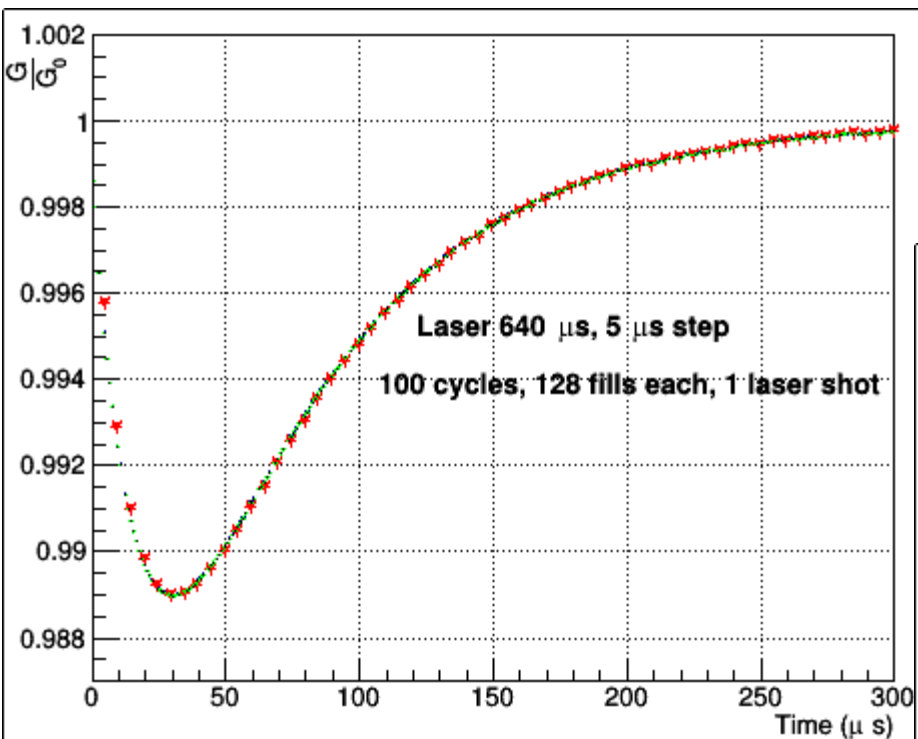


# Laser Shots with 320 $\mu\text{s}$ rate

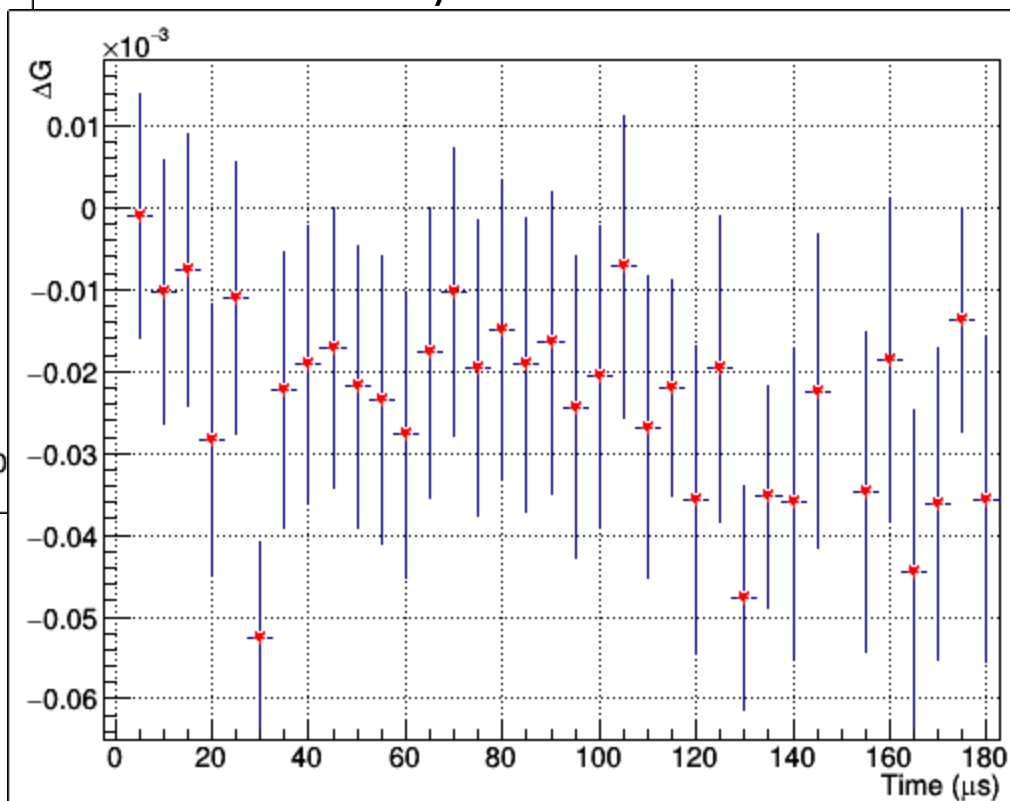
Difference of Laser and  
Muons Only



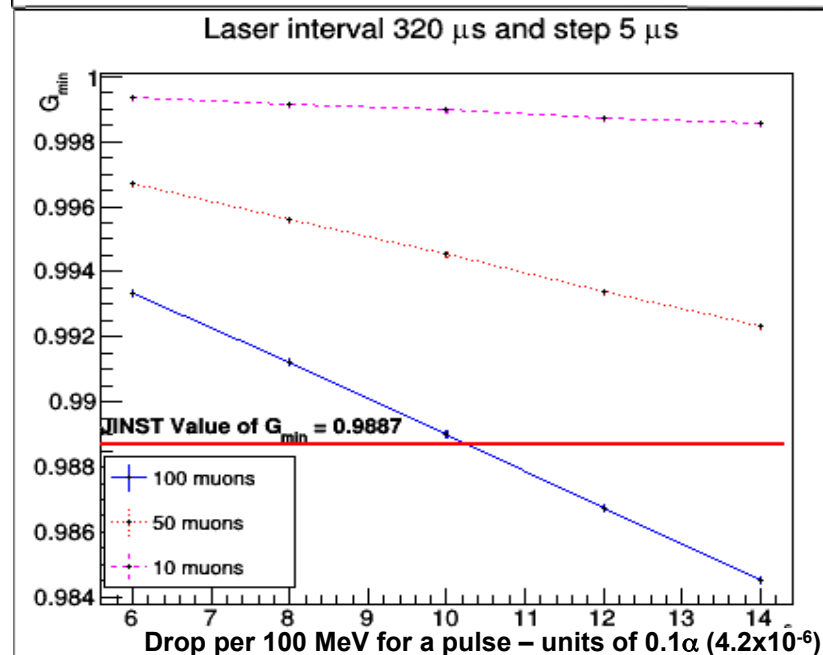
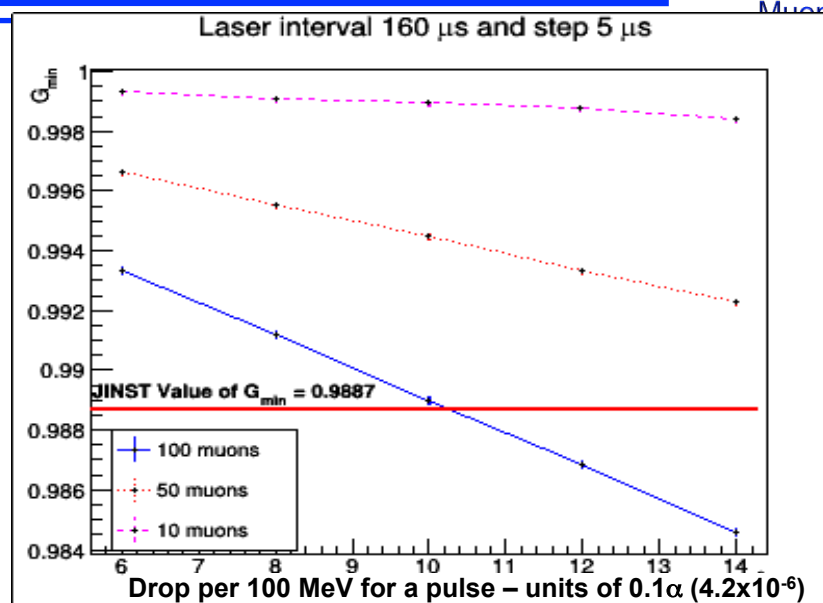
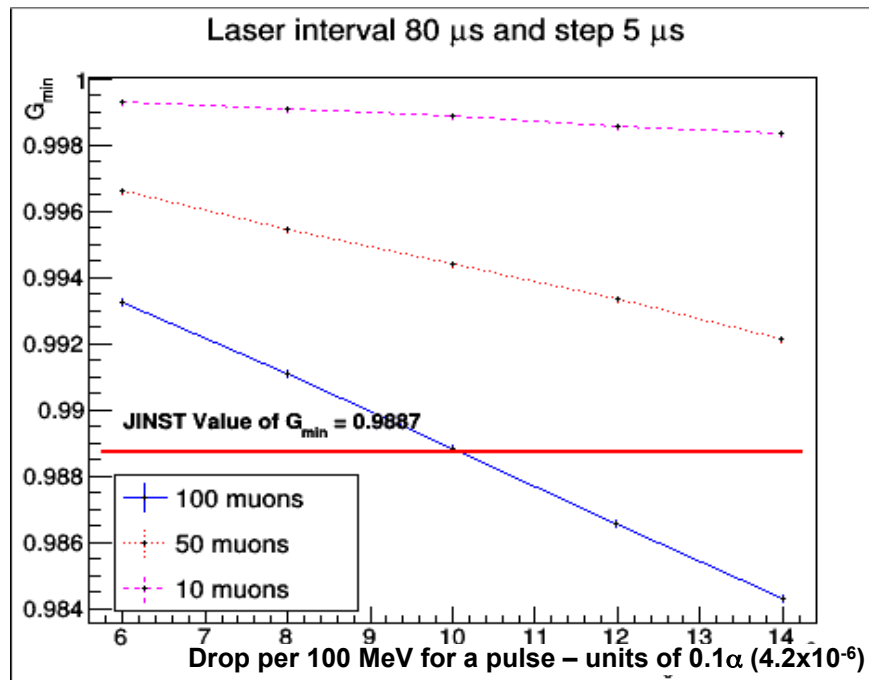
# Laser Shots with 640 $\mu\text{s}$ rate



Difference of Laser and  
Muons Only



# Optimizing the Drop in Gain per Pulse and Number of Pulses



- Calibration procedure will mostly be based on in- and out-of fills.
- We concentrate on the in-fill procedure trying to evaluate the effects of the laser pulses on the gain.
- A semi-analytical approach is used to study the shape of average gain within a fill.
- A realistic gain effect was considered (BV) which depends on the number of muons times the energy drop.
- By assuming 100 muons per fill and  $4.2 \times 10^{-5}$  drop @100 MeV we were able to study the effects of the laser pulse on the gain.
- By pulsing the laser at 2 GeV the effect with a repetition gain goes from  $\sim 10^{-4}$  (at 80  $\mu$ s separation, 8 pulses per fill) to  $2 \times 10^{-5}$  at 640  $\mu$ s separation.
- We can refine our studies including more realistic effects, like  $\omega_a$ , different (short-long) recovering times and correct energy & rate for individual crystals.
- We have a documentation in progress.

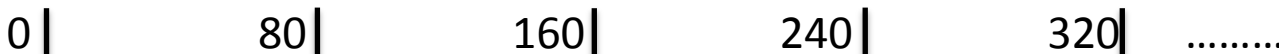
# BACK-UP SLIDES

- Effect of gain fluctuations on the uncertainties and  $\omega_a$ . Can have infill and out of fill effects (negligibly small as they are due to slow variations). Consider only infill effects. Reduce error due to gain changes to 20 ppb.
- Study and simulate gain fluctuations/stability of SiPMs based on the BV sagging effects studied by Aaron , introducing a perturbation in gain function  $G(t) = (G' - G_0)$  where  $G_0$  is the ideal/corrected gain and  $G'$  is true gain vs. time due to detector readouts etc.
- A very stable laser calibration system used which monitors the source for stability/fluctuation before calibration which gives  $G_0$  and  $G'$  is measured using the above – laser through calorimeters.
- Simulate the effect of laser pulses on this SiPM's gain function.

# Special cases – Number of fills and lasers

8 Laser shots with 80 ms time interval (corresponding to 12.5 kHz) – 2000 cycles

**Fill 1:**



**Fill 2:**



....

**Fill 16:**



4 Laser shots with 160 ms 1000 cycles

**Fill 1:**



**Fill 2:**



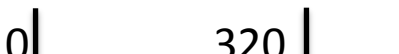
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**Fill 32:**



2 Laser shots with 320 ms 500 cycles

**Fill 1:**



**Fill 2:**



....

**Fill 64:**



1 Laser shot with 640 ms 250 cycles

**Fill 1:**



**Fill 2:**



....

**Fill 64:**

